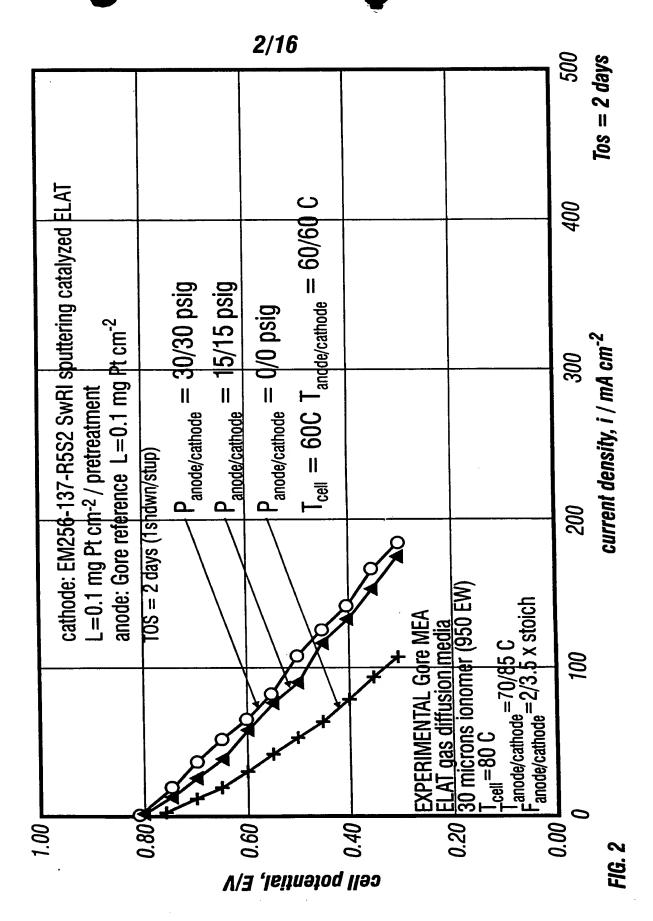
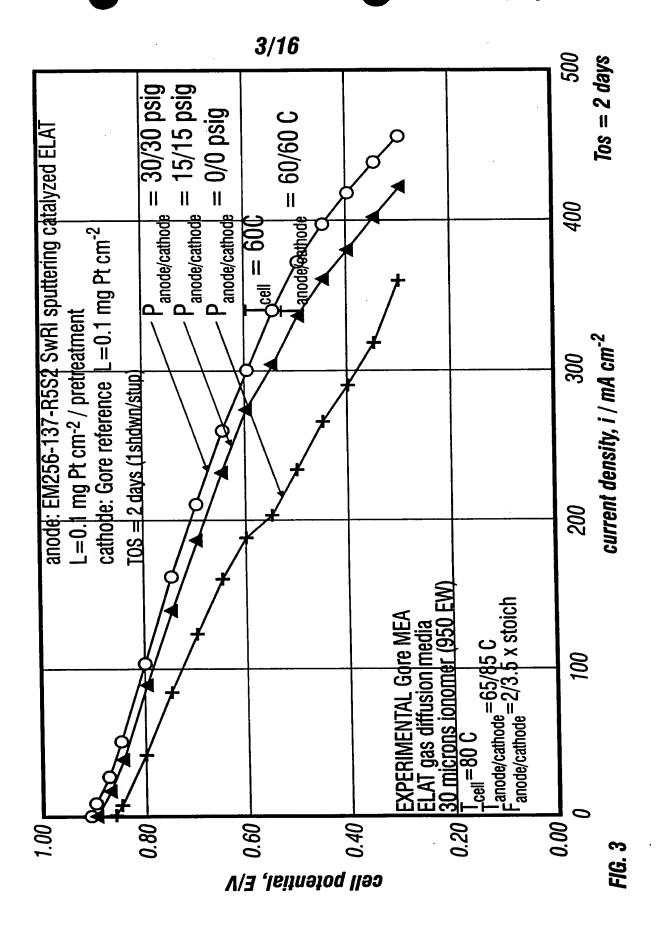


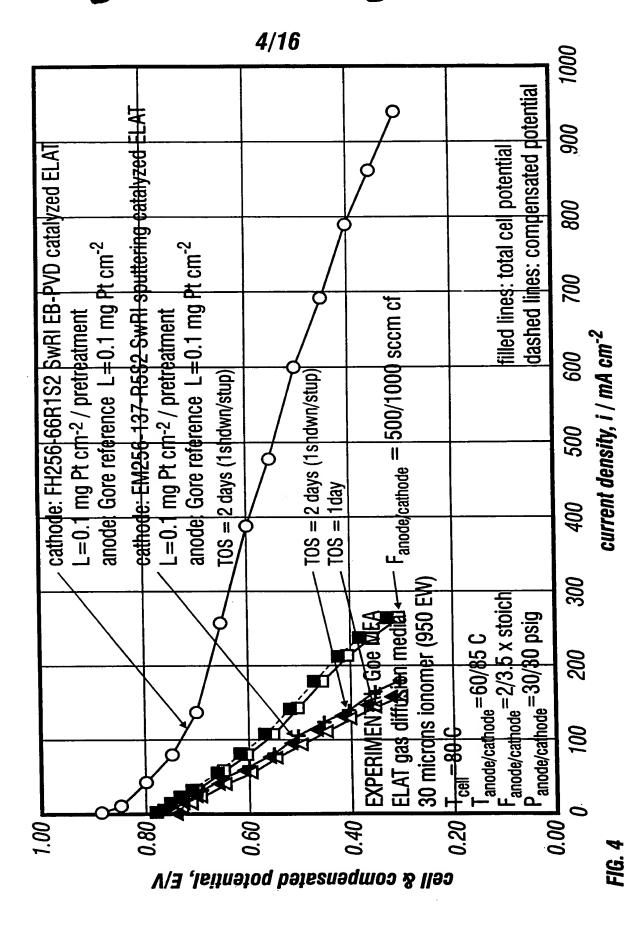
AMENDED SOMET



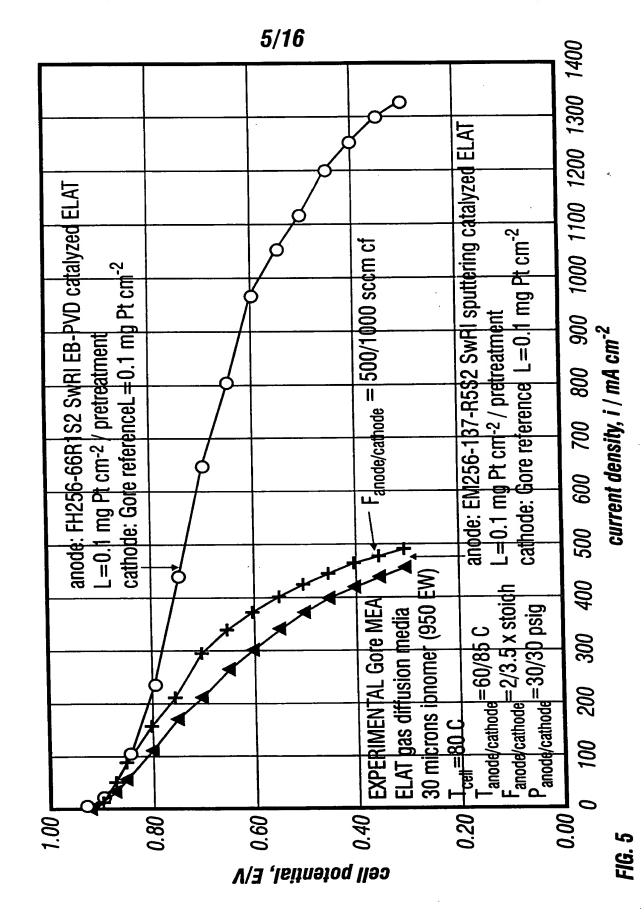
Maria difficult



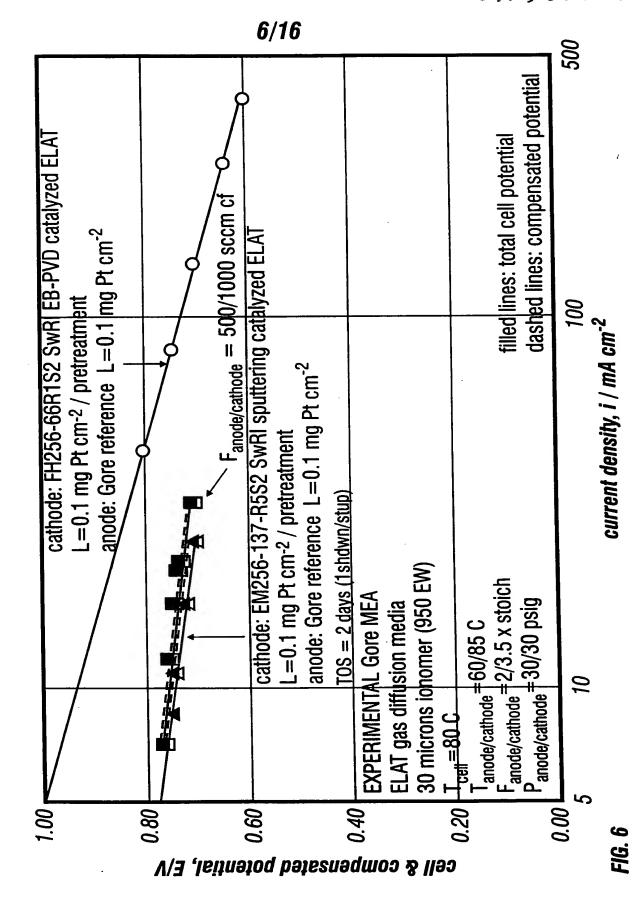
Fr.



U. T. S.



क्षित्रकार्य केस्ट्रा



ALIENDED SHEET

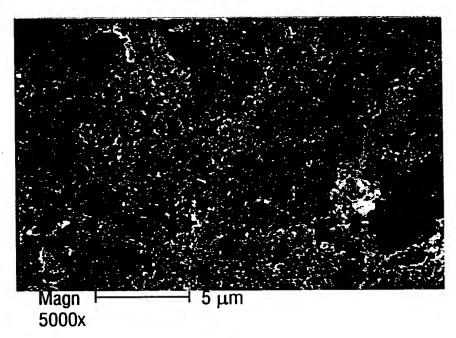


FIG. 7

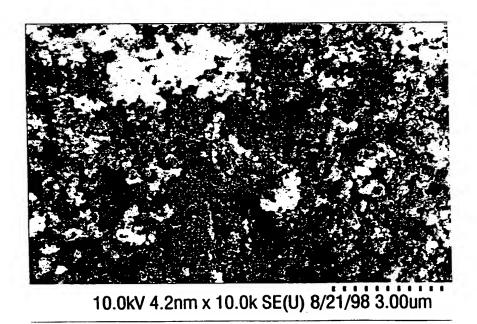
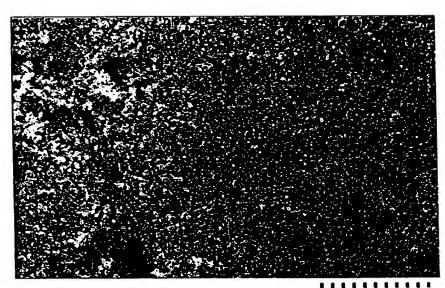


FIG. 8



10.0kV 4.2nm x 50.0k SE(U) 8/21/98 600nm

FIG. 9



ebpvd 10.0kV 5.0nm x 5.00k SE(U) 8/21/98 6.00um FIG. 10

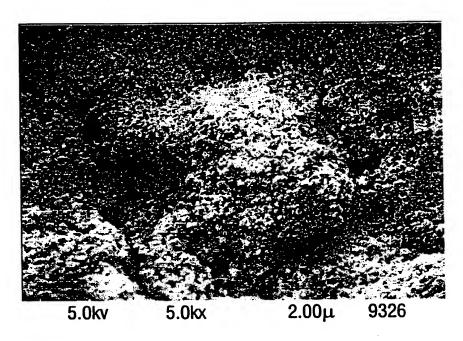
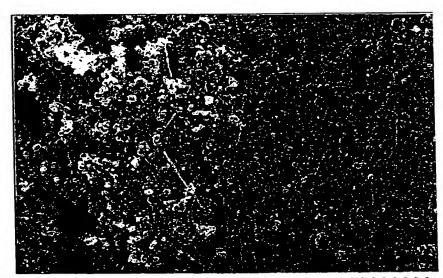
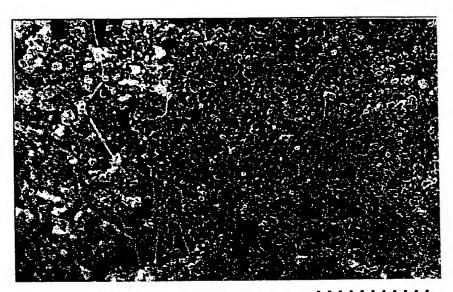


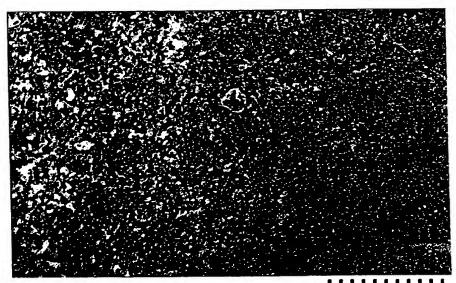
FIG. 11



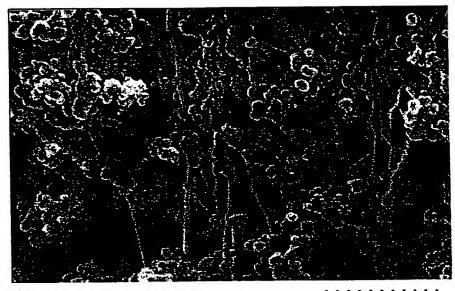
10.0kV 5.0nm x 10.00k SE(U) 8/21/98 3.00um FIG.12



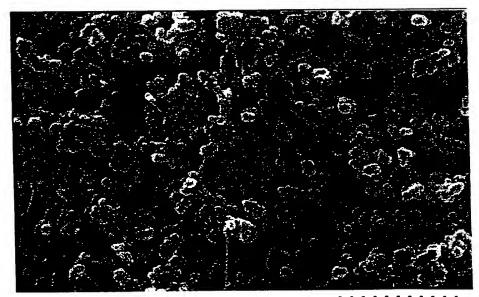
ebpvd10.0kV 5.0nm x 10.0k SE(U) 8/21/98 3.00um FIG. 13



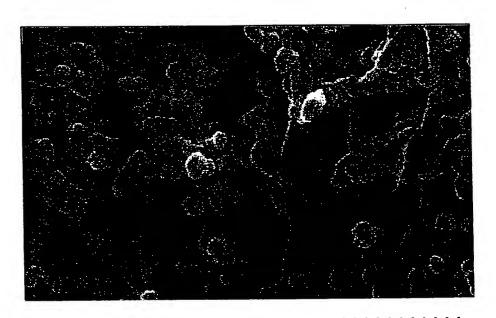
10.0kV 5.0nm x 5.00k SE(U) 8/21/98 6.00um



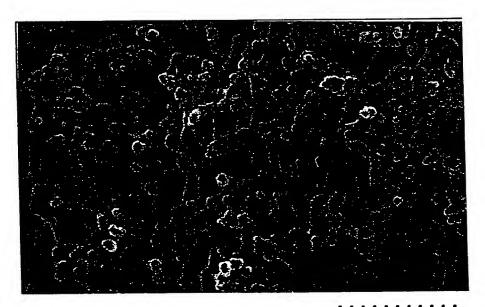
10.0kV 5.0nm x 25.0k SE(U) 8/21/98 1.20um FIG. 15



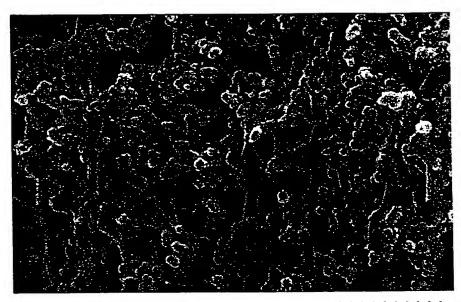
10.0kV 5.0nm x 25.0k SE(U) 8/21/98 1.20um FIG. 16



ebpvd 10.0kV 5.0nm x 50.0k SE(U) 8/21/98 600nm FIG. 17



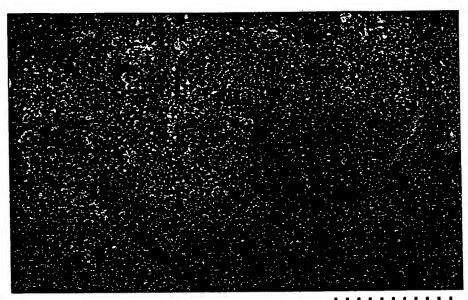
10.0kV 5.0nm x 25.0k SE(U) 8/21/98 1.20um *FIG. 18* 



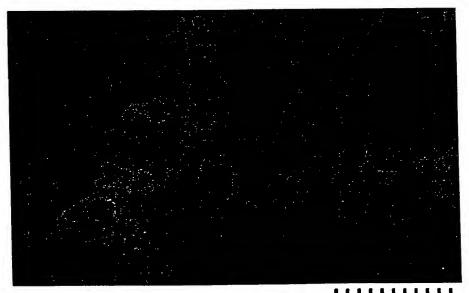
ebpvd 10.0kV 5.0nm x 25.0k SE(U) 8/21/98 1.20um FIG. 19



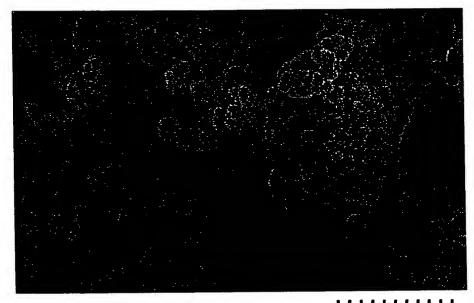
ebpvd 10.0kV 5.0nm x 50.0k SE(U) 8/21/98 600nm *FIG. 20* 



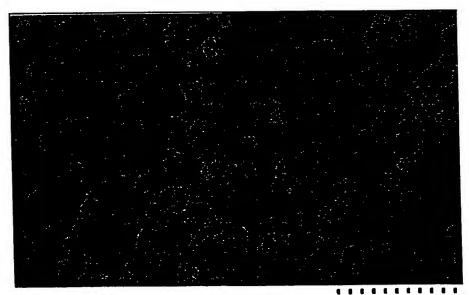
sputter 10.0kV 4.2nm x 5.00k SE(U) 8/21/98 6.00um FIG. 21



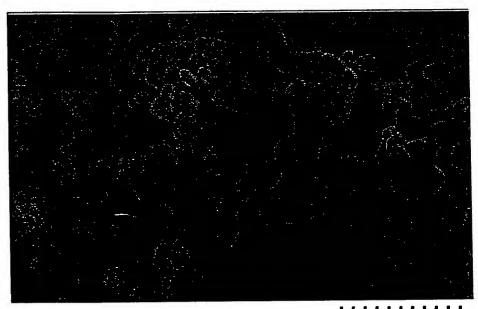
sputter 10.0kV 4.2nm x 50.0k SE(U) 8/21/98 6.00nm FIG. 22



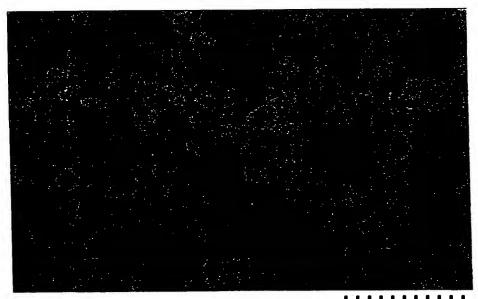
sputter 10.0kV 4.2nm x 50.0k SE(U) 8/21/98 600nm FIG. 23



sputter 10.0kV 4.2nm x 25.0k SE(U) 8/21/98 1.20um FIG. 24



sputter 10.0kV 4.2nm x 50.0k SE(U) 8/21/98 600nm FIG. 25



sputter 10.0kV 4.2nm x 25.0k SE(U) 8/21/98 1.20um FIG. 26